# Monthly LabAdviser/Process2Share update: 28/8 2015

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| Updated Subject  | Contributor | Link to the updated pages |
| **E-beam**Introduction to E-beam writer BEFORE you request for training:User Manual for JEOL JBX-9500User Manual for BEAMER:User Manual for Preparation of sdf and jdf files | **Tine Greibe @danchip** | [EBeamLithography#Getting\_started](http://labadviser.danchip.dtu.dk/index.php/Specific_Process_Knowledge/Lithography/EBeamLithography#Getting_started)[EBeamLithography/JBX9500Manual](http://labadviser.danchip.dtu.dk/index.php/Specific_Process_Knowledge/Lithography/EBeamLithography/JBX9500Manual)[EBeamLithography/BEAMER](http://labadviser.danchip.dtu.dk/index.php/Specific_Process_Knowledge/Lithography/EBeamLithography/BEAMER)[EBeamLithography/FilePreparation](http://labadviser.danchip.dtu.dk/index.php/Specific_Process_Knowledge/Lithography/EBeamLithography/FilePreparation) |
| **TiO2 with ALD -trenches**Update on the TiO2 with ALD main pageTiO2 deposition in trenches | **Pernille V. Larsen****@danchip****Evgeniy Shkodin @Fotonik/Danchip** | [TiO2\_deposition\_using\_ALD](http://labadviser.danchip.dtu.dk/index.php/Specific_Process_Knowledge/Thin_film_deposition/ALD_Picosun_R200/TiO2_deposition_using_ALD)[TiO2\_deposition\_using\_ALD/TiO2\_deposition\_on\_trenches\_using\_ALD](http://labadviser.danchip.dtu.dk/index.php/Specific_Process_Knowledge/Thin_film_deposition/ALD_Picosun_R200/TiO2_deposition_using_ALD/TiO2_deposition_on_trenches_using_ALD) |
| **Multipurpose Anneal Furnace**New equipment page on the new Multipurpose annealing furnace + this furnace has been included in the annealing and oxidation comparison pages. | **Pernille V. Larsen****@danchip** | [Furnace:\_Multipurpose\_annealing](http://labadviser.danchip.dtu.dk/index.php/Specific_Process_Knowledge/Thermal_Process/Furnace%3A_Multipurpose_annealing)[Oxidation#Comparison\_of\_the\_seven\_oxidation\_furnaces](http://labadviser.danchip.dtu.dk/index.php/Specific_Process_Knowledge/Thermal_Process/Oxidation#Comparison_of_the_seven_oxidation_furnaces)[Oxidation#Comparison\_of\_the\_seven\_oxidation\_furnaces](http://labadviser.danchip.dtu.dk/index.php/Specific_Process_Knowledge/Thermal_Process/Oxidation#Comparison_of_the_seven_oxidation_furnaces) |
| **SEM Inspect S (CEN)**Equipment page has been made | **Berit Wenzell @CEN** | [SEM\_Inspect\_S](http://labadviser.danchip.dtu.dk/index.php/Specific_Process_Knowledge/Characterization/SEM_Inspect_S) |
| **Update on Survey 2015** | **Mette, Anders, Leif and Thøger @danchip** | <May_2015_Survey> |

# Equipment Manuals updated in LabManager:

As an approved user on a piece of equipment you have to make sure you have read and understood the latest version of the manual before using the equipment.

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| **Manual for Critical Point Dryer** |
| **Manual for Drop Shape Analyzer** |  |